

OXFORD IN YOUR CITY

NOVEMBER 12 2019

FORD CENTER AT THE STAR, 9 COWBOYS WAY, FRISCO, TX, 75034

9:00 - 9:15	WELCOME & REGISTRATION	
9:15 - 9:30	Introduction	Emiel Thijssen
9:30 - 10:00	InP LASER MANUFACTURING: Ensuring the facet is smooth and vertical	Dr Ligang Deng
10:00 - 10:15	COFFEE	
10:15 - 10:45	VCSEL DEVICE MANUFACTURING: Low footing process for maximum device performance	Stephanie Baclet
10:45 - 11:15	ION BEAM ETCHING AND DEPOSITION: Laser Facet Processing by Ion Beam Sputtering	Pauline Alvarez
11:15 - 11:45	ATOMIC LAYER ETCHING: A new technique for ultra precise and low damage etching	Dr Mark Dineen
11:45 - 12:45	MEET THE EXPERTS: ASK US ANYTHING! 1:1 BREAKOUT SESSIONS	
12:45 - 13:15	LUNCH BREAK	
13:15 - 13:45	STADIUM TOUR	
13:45 - 14:15	ALD FOR GaN POWER DEVICES: Fast plasma enhanced ALD enabling improved interfaces, high quality films & high throughput	Dr Aileen O'Mahony
14:15 - 14:45	SiC POWER DEVICES: Achieving smooth, low defect density substrates and optimum UMOSFET trenches by plasma etching	Dr Mark Dineen
14:45 - 15:00	COFFEE BREAK	
15:00 - 16:00	MEET THE EXPERTS: ASK US ANYTHING! 1:1 BREAKOUT SESSIONS	

